Applicant: Motoyuki Tsuihij et al Attorney's Docket No.: 10417-092002 / S21-165933M/KIK

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Amendments to the Claims:

This listing of claims replaces all prior versions and listings of claims in the application:

Listing of Claims:

1-5. (Cancelled)

6. (Currently amended) A recycling method for recycling waste particles, as a material to be melted or mixed, a cake that is obtained by comprising:

solidifying particle generated at a step of machining a crystal ingot into a wafer[,] or at a step of machining a semiconductor wafer;

solidifying into a cake, particles generated by machining the crystal ingot or the semiconductor wafer; and

melting the cake.

7. (Currently amended) A recycling method for recycling waste particles employing as a material to be melted, a cake that is obtained by solidifying particle generated at a step of comprising:

machining a crystal ingot into a wafer[,] or at a step of machining a semiconductor wafer:

solidifying into a cake, particles generated by machining the crystal ingot or the semiconductor wafer; and for

recycling said cake as an ingot.

8. (Currently amended) A recycling method for recycling waste particles employing as a material to be melted, a cake that is obtained by solidifying, at a predetermined water content, particles generated at a step of comprising:

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machining a crystal ingot <u>in</u>to a wafer[,] or at a step of machining a semiconductor wafer;[,]

solidifying into a cake at a predetermined water content, particles generated by machining the crystal ingot or the semiconductor wafer; and for melting said cake recycling to recycle said cake as an ingot.

9. (Currently amended) A method for fabricating a semiconductor ingot wherein a cake that is obtained by solidifying, at a predetermined water content and without a reaction with a chemical occurring, particles generated at a step of comprising:

machining a crystal ingot <u>in</u>to a wafer[,] or at a step of machining a semiconductor wafer; , is employed as a material to be molted

solidifying into a cake at a predetermined water content and without any chemical reactions, particles generated by machining the crystal ingot or the semiconductor wafer; and melting said cake.

- 10. (Currently amended) A recycling method according to one of claims 6 to 8, wherein said machining step is an comprises abrading, grinding or polishing, dicing, back grinding or wafer polishing step.
- 11. (Currently amended) A method according to claim 9, wherein said machining step is an comprises abrading, grinding or polishing, dicing, back grinding or wafer polishing step.
 - 12- 18. (Cancelled)
- 19. (New) A method for processing particles comprising:
 solidifying into a cake, particles that are generated by machining a crystal ingot into a
 wafer or machining a semiconductor wafer; and

melting the cake into an ingot.

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20. (New) A method according to claim 19, further comprising: solidifying said particles at a predetermined water content, without any chemical reactions.

- 21. (New) A method according to claim 19, wherein machining comprises abrading, grinding or polishing.
- 22. (New) A method according to claim 19, wherein machining said semiconductor wafer comprises dicing, back grinding or wafer polishing.
 - 23. (New) A method according to claim 19, wherein said particles comprises Si flakes.
- 24. (New) A recycling method for recycling waste particles, comprising: melting a cake which is produced by solidifying particles generated by machining a crystal ingot into a wafer or machining a semiconductor wafer.
- 25. (New) A recycling method for recycling waste particles comprising: melting a cake to recycle the cake as an ingot, said cake produced by solidifying particles generated by machining a crystal ingot or a semiconductor wafer at a predetermined water content.
- 26. (New) A method for fabricating a semiconductor ingot comprising: melting a cake which is produced by solidifying particles generated by machining a crystal ingot or a semiconductor wafer at a predetermined water content and without any chemical reactions.
 - 27. (New) A method for processing particles comprising: melting a cake into an ingot, said cake produced by solidifying particles that are

generated by machining a crystal ingot into a wafer or machining a semiconductor wafer.